

Notice of References Cited	Application/Control No. 09/886,511	Applicant(s)/Patent Under Reexam Coates et al.	
	Examiner Rodney McDonald	Art Unit 1753	Page 1 of 1

U.S. PATENT DOCUMENTS

	Document Number Country Code-Number-Kind Code	Date MM-YYYY ¹	Name	Classification ²	
A	6,217,722	4/2001	Jankowski et al.	204	192.21
B	5,367,285	11/1994	Swinehart et al.	338	308
C	4,591,417	5/1986	Kaiser et al.	204	192.23
D	4,491,431	1/1985	Aviram et al.	400	241.1
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FOREIGN PATENT DOCUMENTS

	Document Number Country Code-Number-Kind Code	Date MM-YYYY ¹	Country	Name	Classification ²	
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NON-PATENT DOCUMENTS

	Include, as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages
U	Hohenstein, "Cermet Resistors by Concurrent rf and dc Sputtering", Communications, October 1967, pp.65-66.
V	
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* A copy of this reference is not being furnished with this Office action. See MPEP § 707.05(a).

¹ Dates in MM-YYYY format are publication dates.

² Classifications may be U.S. or foreign.